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Express Label No: ER 408659792 US

Karen Cing-Mars 12/5/03
(Signature & date)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : December 5, 2003
Allen et al. : Group Art Unit:
Serial No. : Examiner:
Filed: Herewith : IBM Corporation
Dept. 18G/Bldg. 300-482
Based on: 2070 Route 52,
Serial No. 10/320,842 Hopewell Junction, NY 12533
Filed: December 16, 2002 :
Title: MAGNETIC MIRROR FOR
PROTECTION OF CONSUMABLE PARTS
DURING PLASMA PROCESSING :

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

As a means of complying with the duty of disclosure set forth in 37 CFR 1.56, Applicants are hereby filing an Information Disclosure Statement pursuant to 37 CFR 1.97 and 37 CFR 1.98. The references listed are those which were cited in

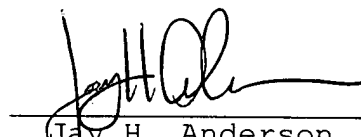
Based on Serial No. 10/320,842

Applicants' parent patent application, U.S. Patent Application Serial No. 10/320,842, filed December 16, 2002.

A summary of all the references is made on Form PTO-1449, attached hereto. Pursuant to 37 CFR 1.98(d), copies of all the references are not being provided as they were previously cited and submitted in Applicants' parent Application noted above.

The Examiner is respectfully requested to consider each reference and initial a copy of Form PTO-1449 and return a copy of same to Applicants.

Respectfully submitted,



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INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket Number (Optional)

FIS920020093US2

Application Number

Applicant(s)

Allen et al.

Filing Date

Group Art Unit

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		5,246,532	09-21-93	Ishida			
		6,251,792	06-26-01	Collins et al.			
		6,068,784	05-30-00	Collins et al.			
		5,888,414	03-30-99	Collins et al.			
		5,707,486	01-13-98	Collins			
		5,556,501	09-17-96	Collins et al.			
		2002/0004309 A1	01-10-02	Collins et al.			

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

		"Wafer Arcing - Etch's Secret Hurdle" Shawming Ma, Semiconductor International Vol. 25, No. 12, pg. 50

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.